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| Substitute Form PTO-1449 (Modified) DEC 02 2002 Information Disclosure Statement by Applicant (Use separate sheets if necessary) (37 CFR §1.98(b)) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-213002 | Application No. 09/455,991 |
| | Applicant Ohtani, et al. | | |
| | Filing Date December 6, 1999 | Group Art Unit 2815 | |

U.S. Patent Documents

| Examiner Initial | Desig. ID | Patent Number | Issue Date | Patentee | Class | Subclass | Filing Date If Appropriate |
|------------------|-----------|---------------|-------------|-----------------|-------|----------|----------------------------|
| <i>P</i> | AA | 6 365 933 | Apr 2, 2002 | Yamazaki et al. | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |

Foreign Patent Documents or Published Foreign Patent Applications

| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
|------------------|-----------|-----------------|------------------|--------------------------|-------|----------|-------------|----|
| | | | | | | | Yes | No |
| | AL | | | | | | | |
| | AM | | | | | | | |
| | AN | | | | | | | |
| | AO | | | | | | | |
| | AP | | | | | | | |

Other Documents (include Author, Title, Date, and Place of Publication)

| Examiner Initial | Desig. ID | Document |
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| <i>P</i> | AQ | O. Schoenfeld et al., "Crystallization of amorphous silicon by NiSi ₂ precipitates." Thin Solid Films 261 (1995) 236-240. |
| | AR | |
| | AS | |
| | AT | |

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| Examiner Signature <i>[Signature]</i> | Date Considered <i>1/23/02</i> |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |

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|-----------------------|-----------|---------------|--------------|-----------------|-------|----------|----------------------------|
| Examiner Initial | Desig. ID | Patent Number | Issue Date | Patentee | Class | Subclass | Filing Date if Appropriate |
| <i>Q</i> | AA | 5 569 936 | Oct 29, 1996 | Zhang et al. | | | |
| <i>Q</i> | AB | 5 591 987 | Jan 7, 1997 | Yamazaki et al. | | | |
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| <i>Q</i> | AH | 5 677 549 | Oct 14, 1997 | Takayama et al. | | | |
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| <i>Q</i> | AL | 5 814 540 | Sep 29, 1998 | Takemura et al. | | | |
| <i>Q</i> | AM | 5 821 138 | Oct 13, 1998 | Yamazaki et al. | | | |
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| <i>Q</i> | AO | 5 869 363 | Feb 9, 1999 | Yamazaki et al. | | | |
| <i>Q</i> | AP | 5 888 858 | Mar 30, 1999 | Yamazaki et al. | | | |
| <i>Q</i> | AQ | 5 897 374 | Apr 27, 1999 | Lin | | | |
| <i>Q</i> | AR | 6 207 969 | Mar 27, 2001 | Yamazaki | | | |

| Foreign Patent Documents or Published Foreign Patent Applications | | | | | | | | |
|---|-----------|-----------------|------------------|--------------------------|-------|----------|-------------|----|
| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
| | AS | | | | | | Yes | No |
| | AT | | | | | | | |
| | AU | | | | | | | |
| | AV | | | | | | | |
| | AW | | | | | | | |

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| Examiner Signature <i>[Signature]</i> | Date Considered 11/23/02 |
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